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(Not for submission under 37 CFR 1.9	19

Application Number		09600590				
Filing Date		2000-07-19				
First Named Inventor Berna		ard Aspar				
Art Unit		1794				
Examiner Name	Kruer	, Kevin R.				
Attornov Docket Number		034299.268				

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	2	6429094		2002-08	1-06	Maleville et al.						
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Attorney Docket Number		034299-268				

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	2	Ejeckam F.E. et al., "Lattice Engineered Compliant Substrate For Defect-Free Heteroepitaxial Growth", April. Phys. Lett. 70 (13), pp. 1685-1687, March 31, 1997											
	3	Molnar, R.J. et al., "Growth Of Gallium Nitride By Hydride Vapor-Phase Epitaxy", Journal of Crystal Growth, 178, pp. 147-156, 1997.											
	4	Tong, QY. et al, "Semiconductor Wafer Bonding: Science And Technology", John Wiley & Sons, Inc., pp. 8, 9, 10, 11, 17, 24 and 25, 1998.											

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